

<b>Notice of References Cited</b>	Application/Control No. 10/621,885	Applicant(s)/Patent Under Reexamination CHANG ET AL.	
	Examiner John Chavis	Art Unit 2193	Page 1 of 1

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*	C	US-2002/0069399	06-2002	Miloushey et al.	717/108
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